

<b>Notice of References Cited</b>		Application/Control No. 10/645,169	Applicant(s)/Patent Under Reexamination HWANG ET AL.	
		Examiner B. Chen	Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,879,459	03-1999	Gadgil et al.	118/715
	B	US-6,042,652	03-2000	Hyun et al.	118/719
	C	US-6,528,430	03-2003	Kwan et al.	438/763
	D	US-6,391,803	05-2002	Kim et al.	438/787
	E	US-6,174,377	01-2001	Doering et al.	118/729
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.